

Substitute for form 1449B/PTO  <b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION</b>  <b>LISTING OF REFERENCES</b>  <b>June 25, 2010</b>  (Use several sheets if necessary)		ATTORNEY DOCKET NO. 3194.1026-006		APPLICATION NO. 10/523,371	
		FIRST NAMED INVENTOR Jeffrey J. Spiegelman		FILING DATE June 21, 2005	
		EXAMINER Carrillo, Bibi Sharidan		CONFIRMATION NO. 3702	GROUP 1792

U.S. PATENT DOCUMENTS				
Examiner's Initials	Ref. No.	DOCUMENT NUMBER Number-Kind Code (if known)	ISSUE DATE / PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT
	A52	6,116,858	09-12-2000	Narabayashi
	A53	2005/0087133 A1	04-28-2005	Shindo, <i>et al.</i>
	A54	2005/0205114 A1	09-22-2005	Alvarez, Jr., <i>et al.</i>

We are not listing separately any prior U.S. Patent Office communications regarding the cited application(s) because the Examiner has access to any such actions through PAIR.

EXAMINER	DATE CONSIDERED
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### FOREIGN PATENT DOCUMENTS

Examiner's Initials	Ref. No.	DOCUMENT NUMBER Country Code-Number-Kind Code (if known)	DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT
	B21	JP 2002-217157 (A) (English Abstract)	08-02-2002	Tokyo Electron Ltd.
	B22	JP 4305927 (A) (English Abstract)	10-28-1992	Shimada Physical Chem. Ind. Co.
	B23	JP 3-225824 (A) (English Abstract)	10-04-1991	Toshiba Corporation
	B24	WO 2005/078771 A2	08-25-2005	Mykrolis Corporation

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Examiner's Initials	Ref. No.	<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>
	C29	Jiang, X., et al., "Photolithography Advances Push, Purge-Gas Purification," Solid State Technology, pages 53-56 (2002).
	C30	Search Report of Taiwan Patent Application No. 093115628, date of completion of search December 2, 2009.
	C31	International Search Report, Application No. PCT/US2004/017251, date of mailing 11/09/2004.
	C32	Translation of Notice of Rejection (2 <sup>nd</sup> Office Action) for Japanese Patent Application No.: 2006-515059, 5 pages.
	C33	Webster's II New Riverside University Dictionary, 1984, Definitions of "pure" and "transfer".

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